

# Developing High-Resolution Magnetic Microscopy Applications Using NV Centers in Diamond



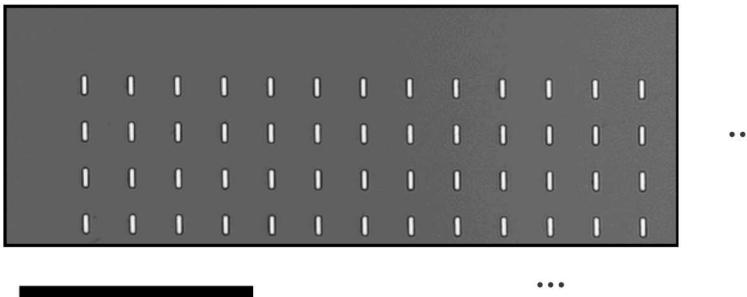
**Pauli Kehayias**  
**Sandia National Laboratories**  
**August 13, 2020**

SAND2020-XXXXX

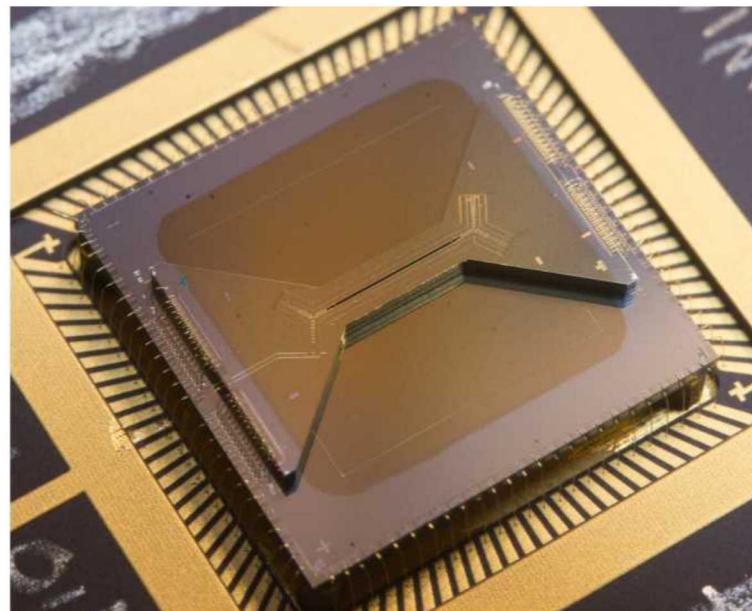
# Magnetic imaging motivations



Micromagnet array

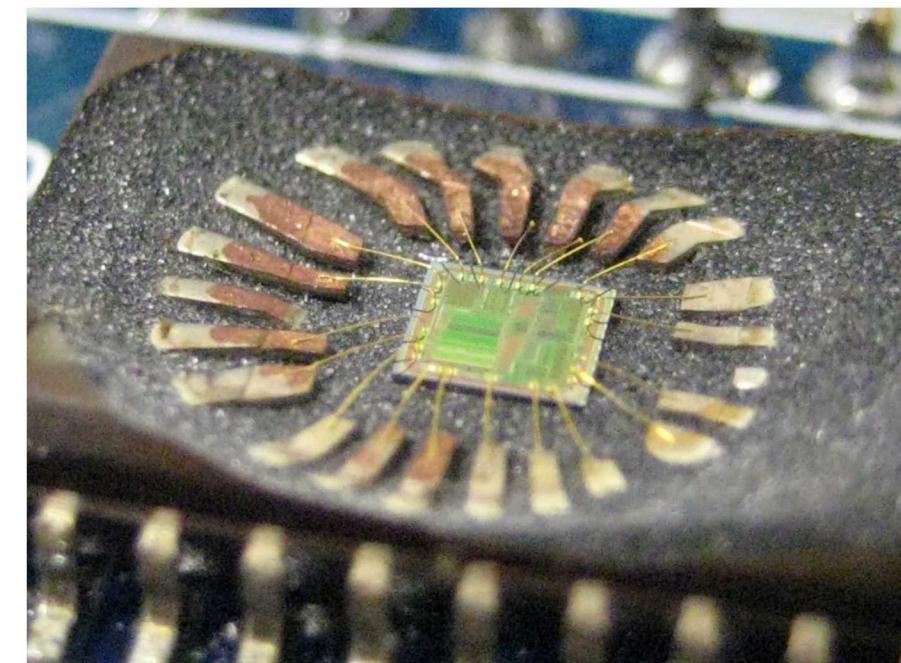


100 x 100 array of nickel micromagnets ( $1 \times 4 \mu\text{m}$ ) with  $10 \mu\text{m}$  spacing



Ion chip characterization for quantum computing

Detecting counterfeits and Trojans in electronics



# Magnetic microscopy wish list



As good as possible:

- Single-pixel sensitivity
- Spatial resolution
- Sample-sensor standoff distance

Also important to consider:

- Operating conditions (bias field, temperature, ...)
- Field of view
- Frequency range
- $|\vec{B}|$ ,  $\vec{B} \cdot \hat{n}$ , or  $\vec{B}$  measurements
- Raster-scanning or parallel readout

# Magnetic microscopy wish list



As good as possible:

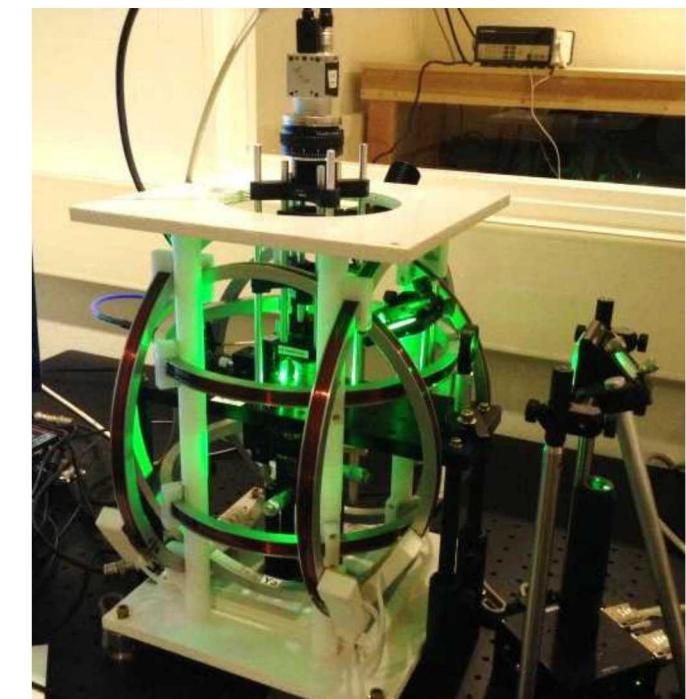
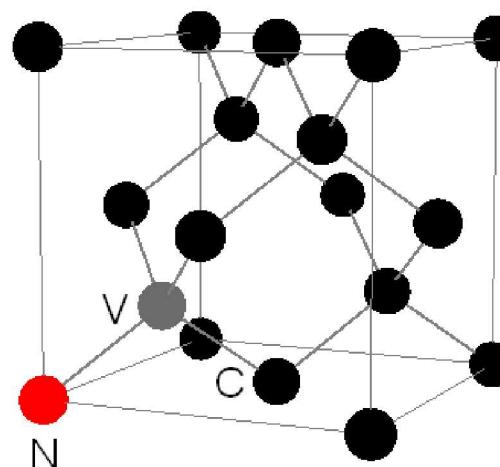
- Single-pixel sensitivity
- Spatial resolution
- Sample-sensor standoff distance

Our approach:

Widefield magnetic  
microscopy using NV centers  
in diamond

Also important to consider:

- Operating conditions (bias field, temperature, ...)
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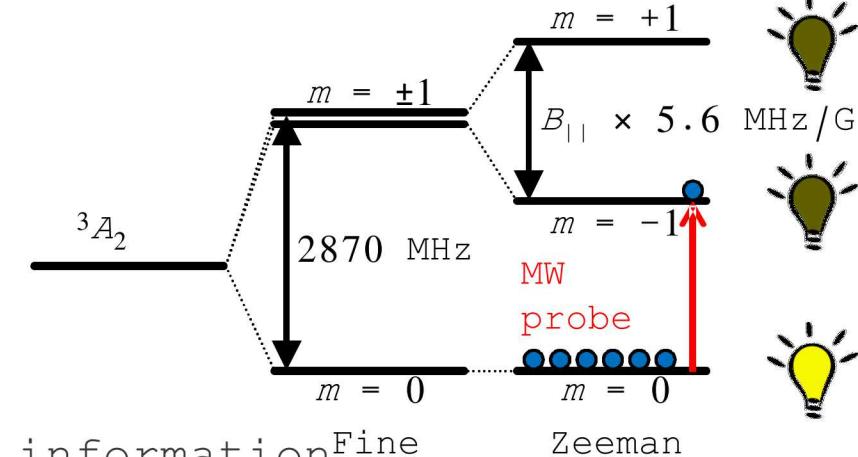
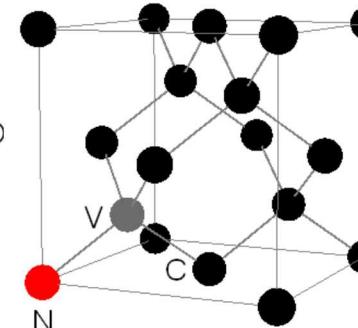
# NV diamond overview



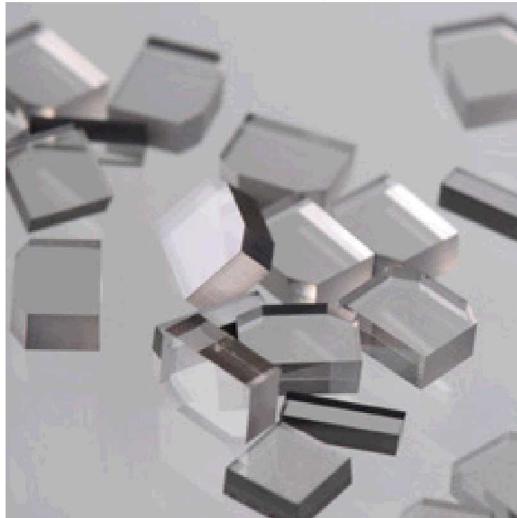
Naturally-occurring paramagnetic color

Discrete electronic states

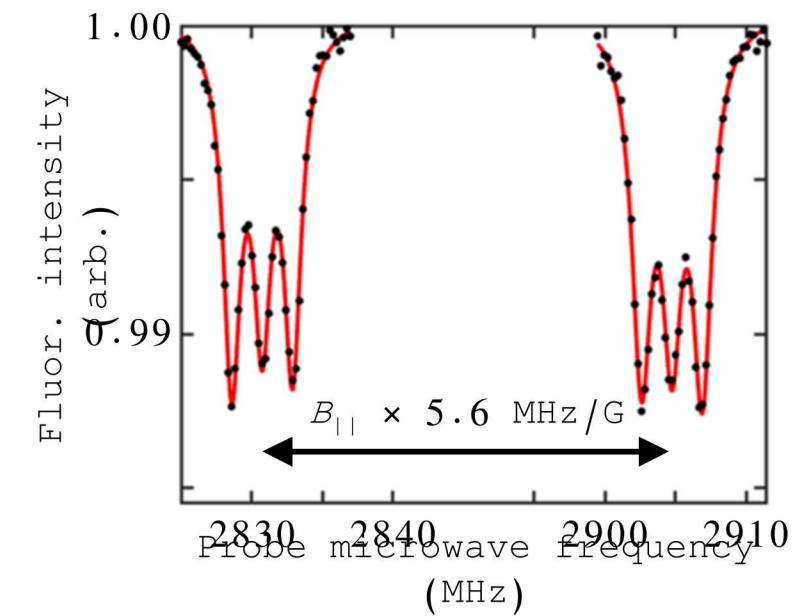
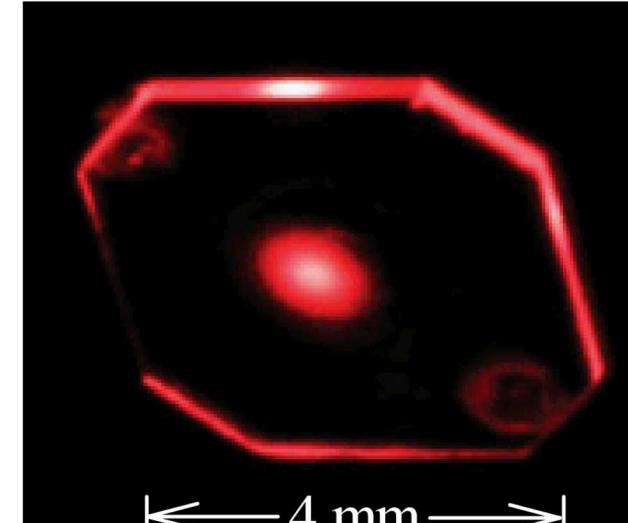
- Magnetically-sensitive ground state
- Optical initialization & readout
- Sublevel-dependent fluorescence
- DC to GHz magnetometry for vector or scalar projection information<sup>Fine</sup>



Synthetic diamond chips  
(few mm)



NV fluorescence under laser  
illumination



# NVs are good for high-res magnetic imaging



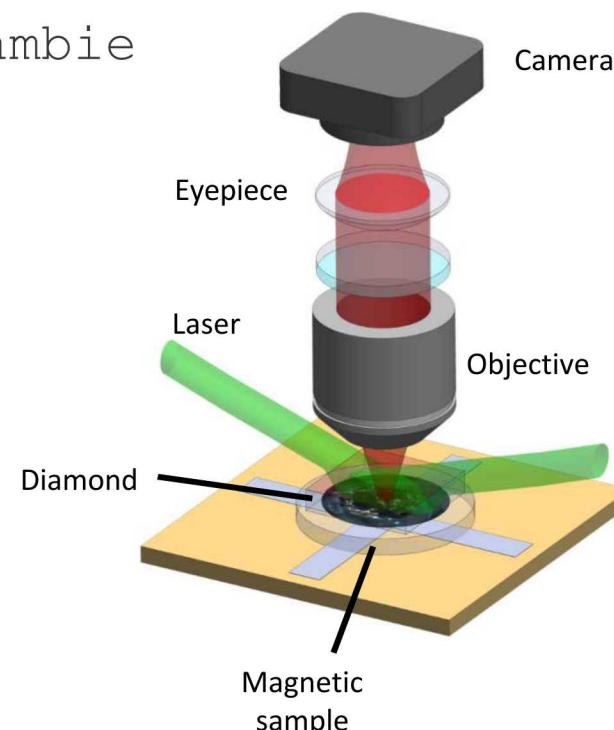
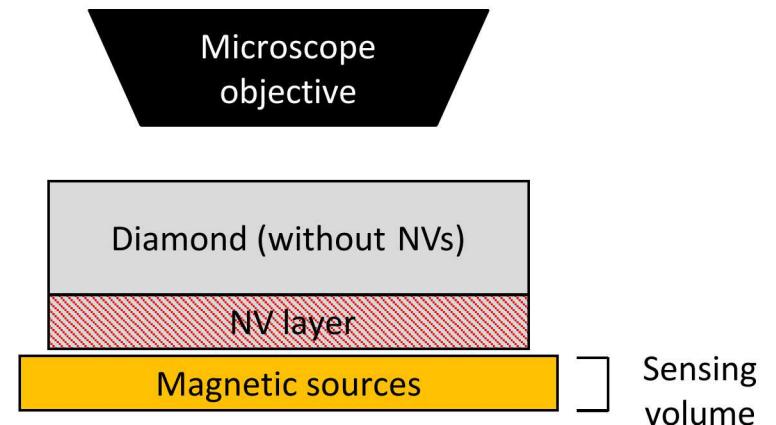
Small sensor-target separation

High magnetic moment sensitivity

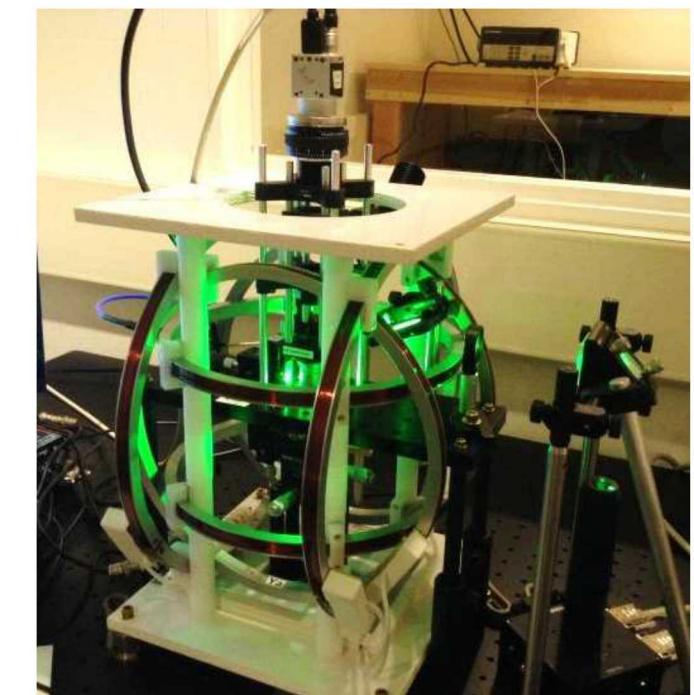
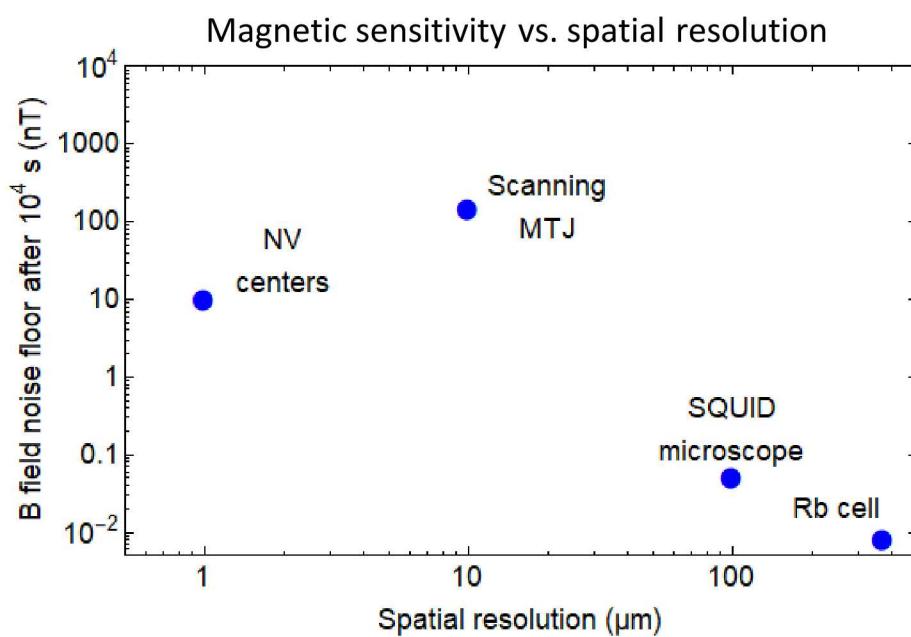
Few-mm FOV, micron-scale spatial resolution

Overlay optical and magnetic images

No sensor scanning, works at ambient



D. R. Glenn et al.,  
Geochem. Geophys. Geosyst.  
18, 8 (2017)



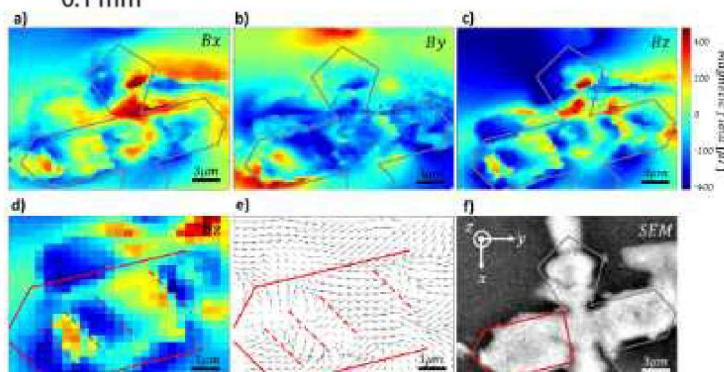
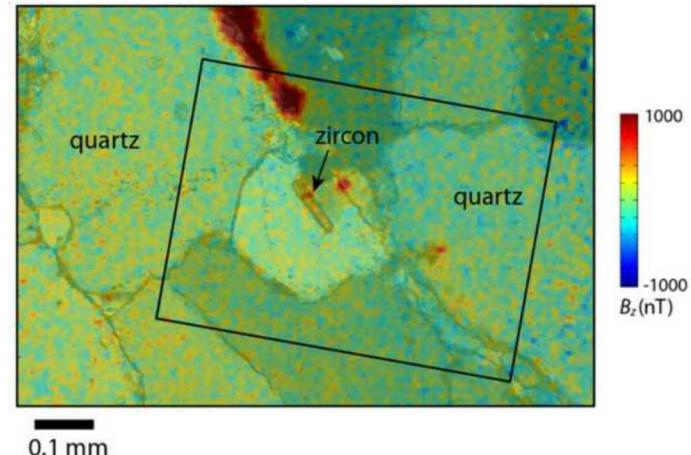
Widefield NV magnetic microscopy setup

# NV magnetic imaging highlights

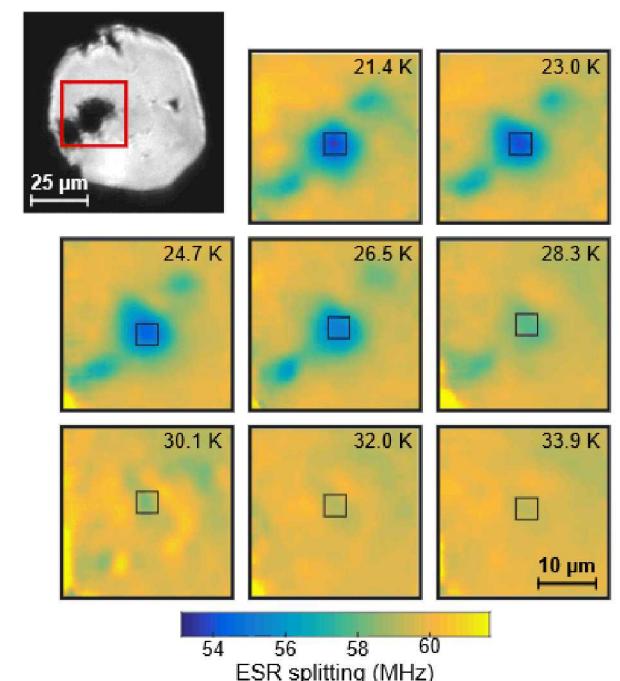
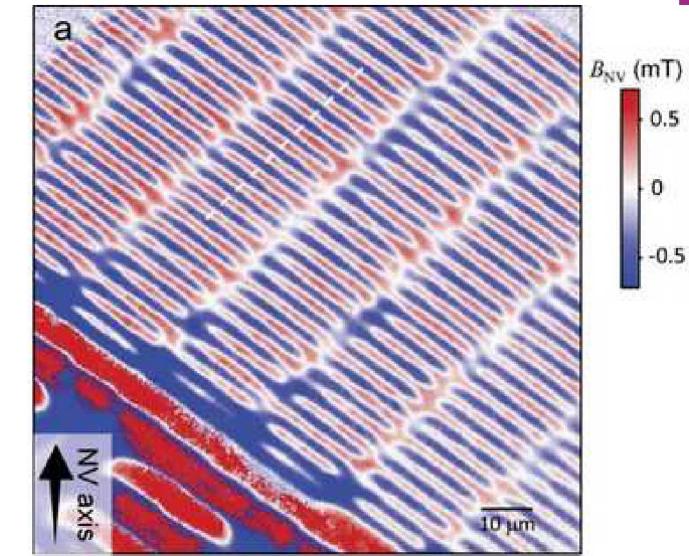
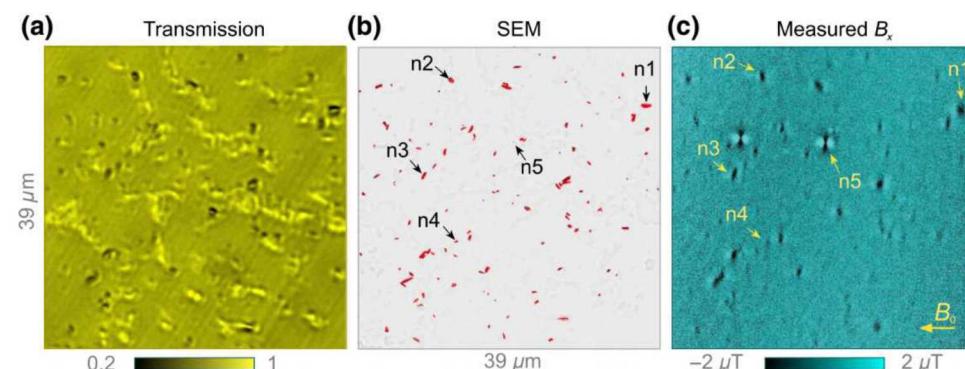
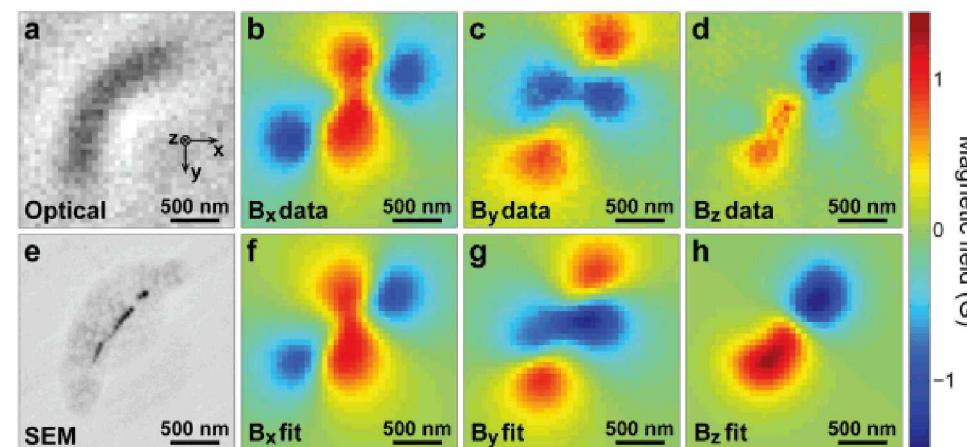


Condensed-  
matter  
physics

Geomagnetism



Biomagnetics



B. P. Weiss et al., Geology 46 5, 427-430 (2018)  
 E. Farchi et al., Spin 07 03 1740015 (2017)  
 D. Le Sage et al., Nature 496, 486-489 (2013)  
 I. Fescenko et al., Phys. Rev. Applied 11 034029 (2019)  
 D. A. Simpson et al., Sci. Rep. 6 22797 (2016)  
 M. Lesik et al., Science 366 6471 (2019)

# Application #1: micromagnet array PUFs



To protect against counterfeiters, tag each object with a unique fingerprint

Requirements for PUFs:

- Easy to make, hard to reproduce individual ones
- Random and unique (difficult to predict)
- Efficient to characterize, reproducible output
- Low-cost, resilient

Examples:

- Fibers in paper
- Manufacturing variations in electronics
- Our work: fabricated micromagnets

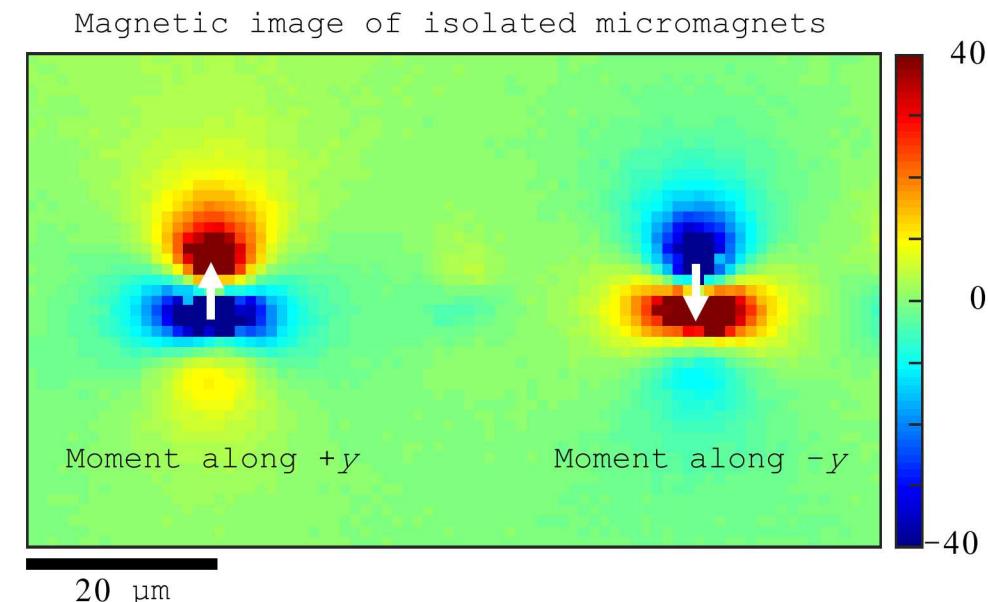
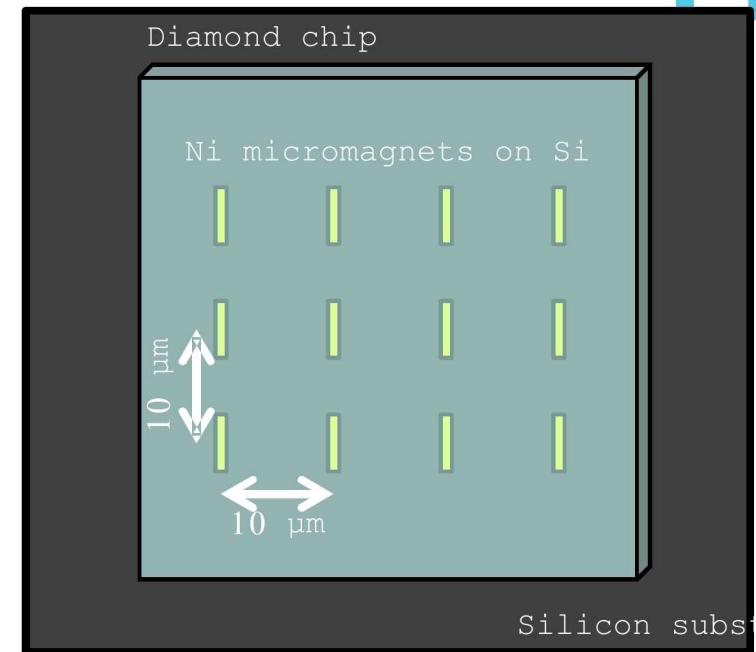
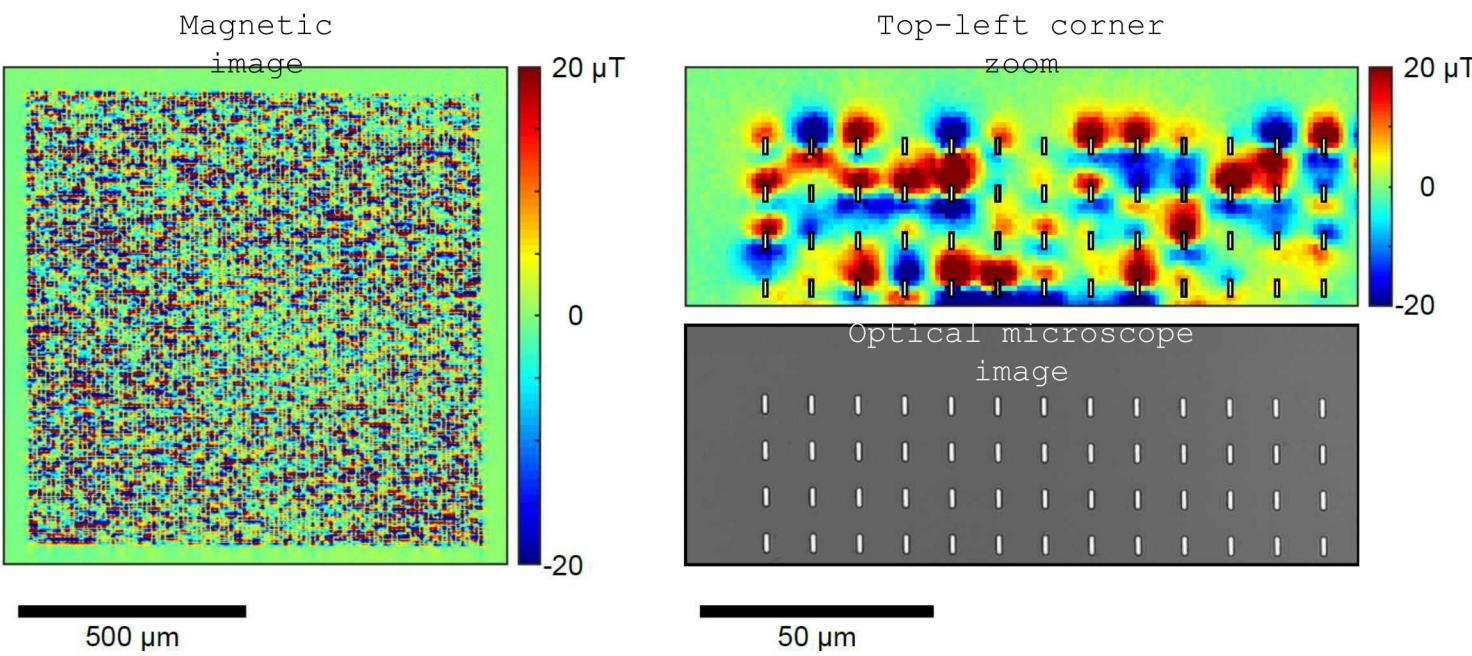


Anti-counterfeiting fibers in a banknote

# Application #1: micromagnet array PUFs

Use a micromagnet array as a PUF

- Each magnet has a random (uncontrollable) magnetization
- Measure each micromagnet, generate a binary {0,1} for each
- Benefits: PUF is unpowered, compact, CMOS-compatible, stable over geological timescales, and can be hidden under a thin opaque layer

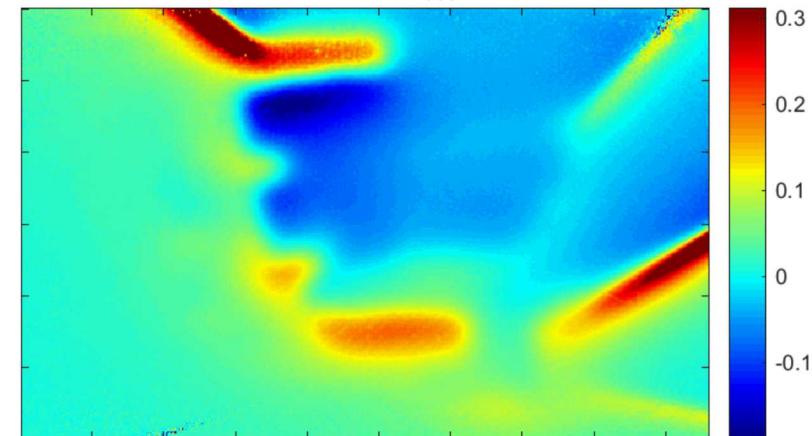
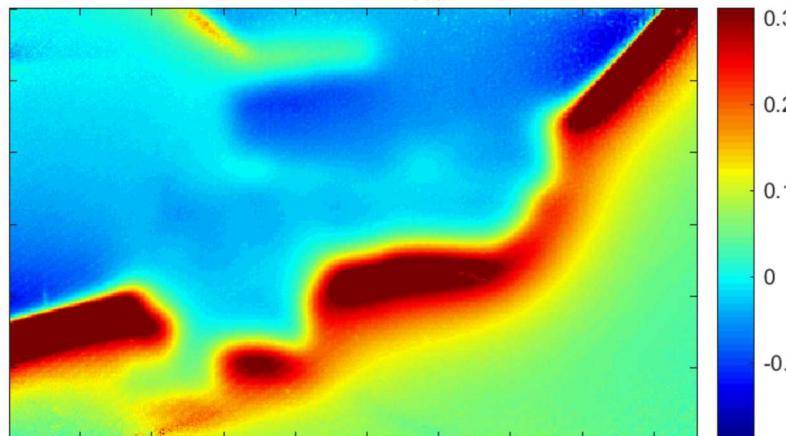
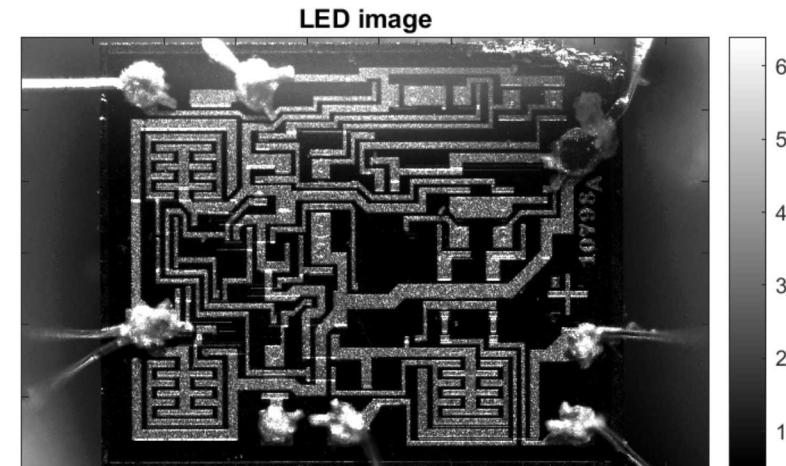
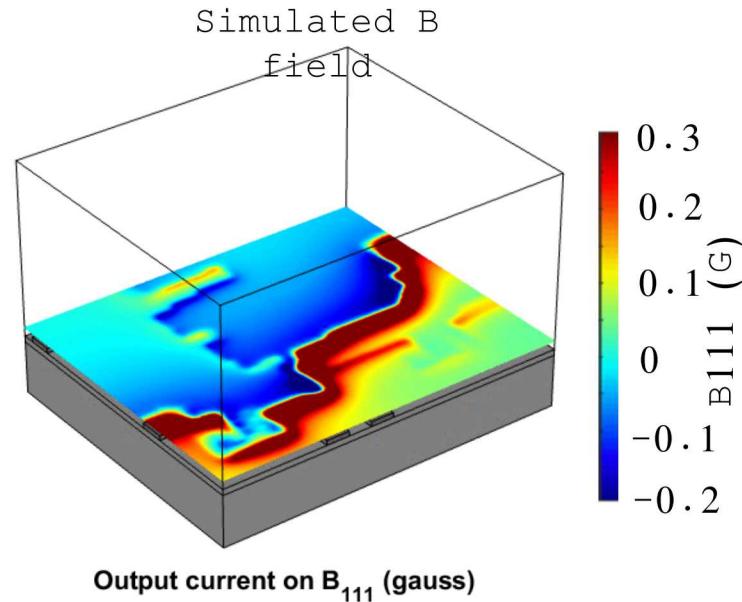


# Application #2: counterfeit electronics probe



Passively interrogate IC behavior and find counterfeits & Trojans

Commercial  
555 timer  
die

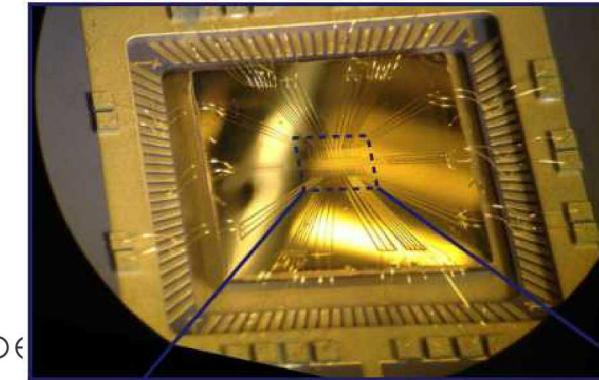


# Application #3: ion chip characterization



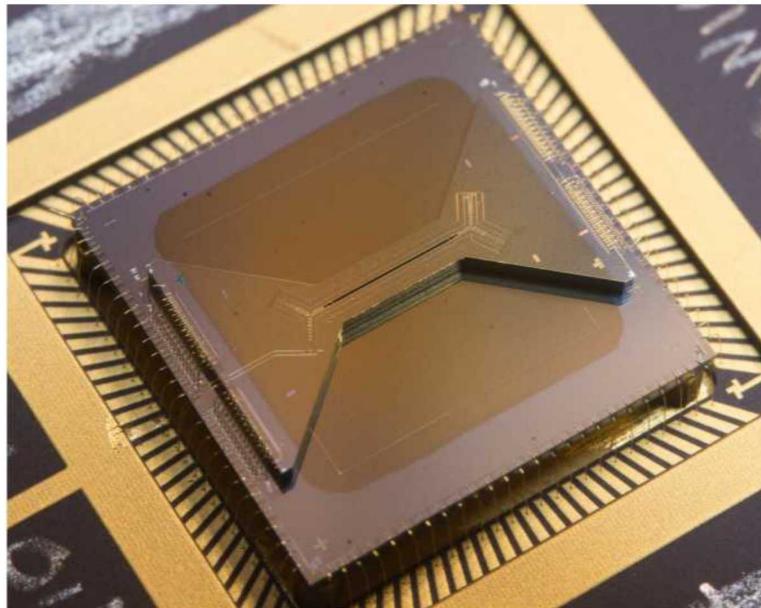
Characterize ion chips over a wide frequency range on chip with 3.2 GHz near-field microwave gates

- DC magnetic gradients
- RF trapping potential (10-100 MHz)
- Microwave chip traps (few GHz)

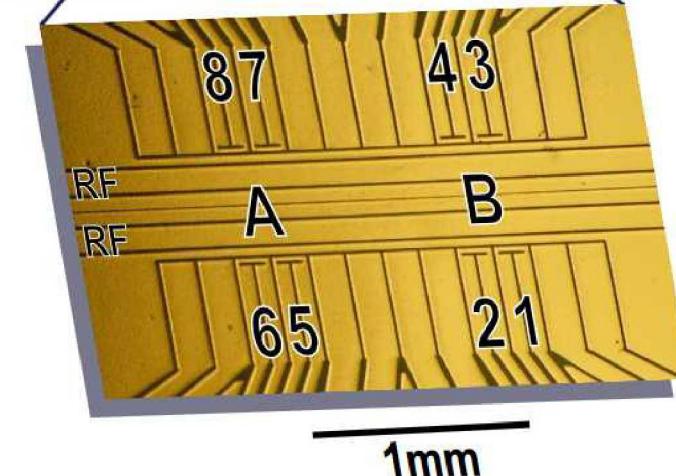


Validate FEM calculation & manufacturing

Test an ion chip before installing it in the experiment



Sandia high-optical-access ion chip



# Summary



As good as possible:

- Single-pixel sensitivity
- Spatial resolution
- Sample-sensor standoff distance

Few  $\mu\text{T}$  after 1 s in a 1  $\mu\text{m}$  pixel

Few microns

As close as  $\sim 10$  nm

Also important to consider:

- Operating conditions
- Field of view
- Frequency range
- $|\vec{B}|$ ,  $\vec{B} \cdot \hat{n}$ , or  $\vec{B}$  measurements
- Raster-scanning or parallel readout

DC to 100 GHz

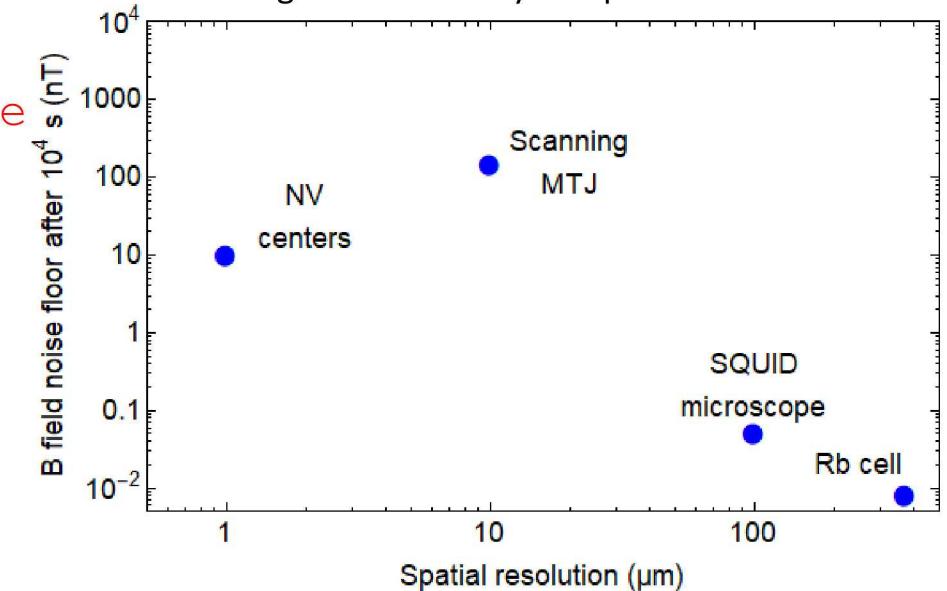
Ambient conditions, arbitrary  $B_0$

$\sim 0.1$  to few mm,  $10^6$  pixels

Magnetic sensitivity vs. spatial resolution

Vector or projec

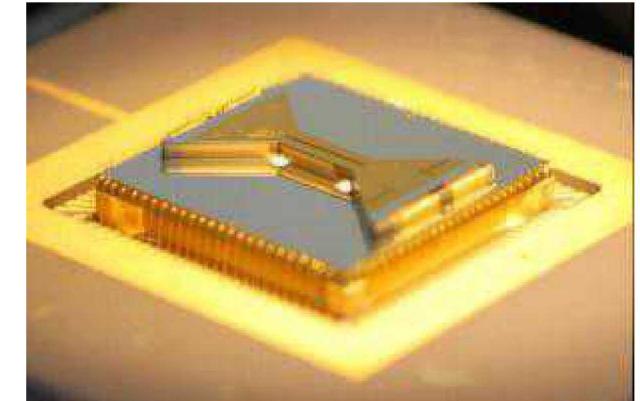
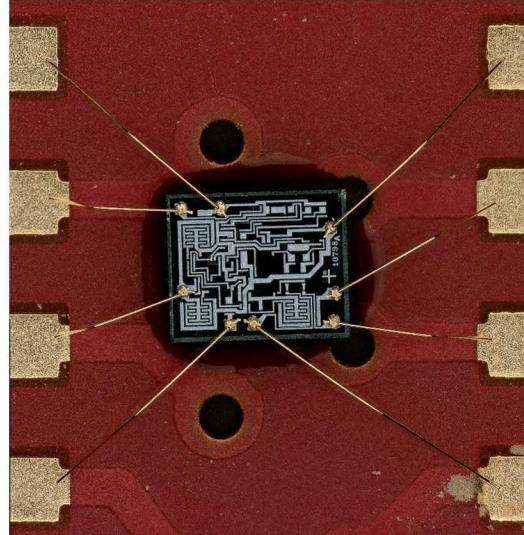
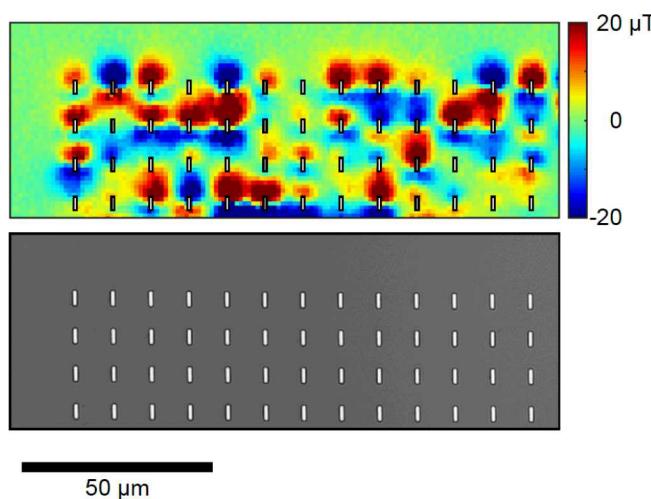
Parallel



# Summary



NV magnetic imaging enables new insights and directions for related fields



Ongoing investigations into alternative optically-active defects:

- SiV, SnV, PbV, ST1, ..., SiC polymorphs, ...

Collaborators:

- Micromagnet PUFs: Ezra Bussmann, Tzu-Ming Lu, Andy Mounce
- IC magnetic imaging: Ray Haltli, Edlyn Levine, Tzu-Ming Lu, Andy Mounce, Denise Tibetts, Darlene Udoni
- Ion chip traps: Susan Clark, Ray Haltli, Melissa Revelle